

# Record tunneling magnetoresistance for one of the world's smallest perpendicular magnetic tunnel junctions

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across MTJs of various sizes. Credit: imec

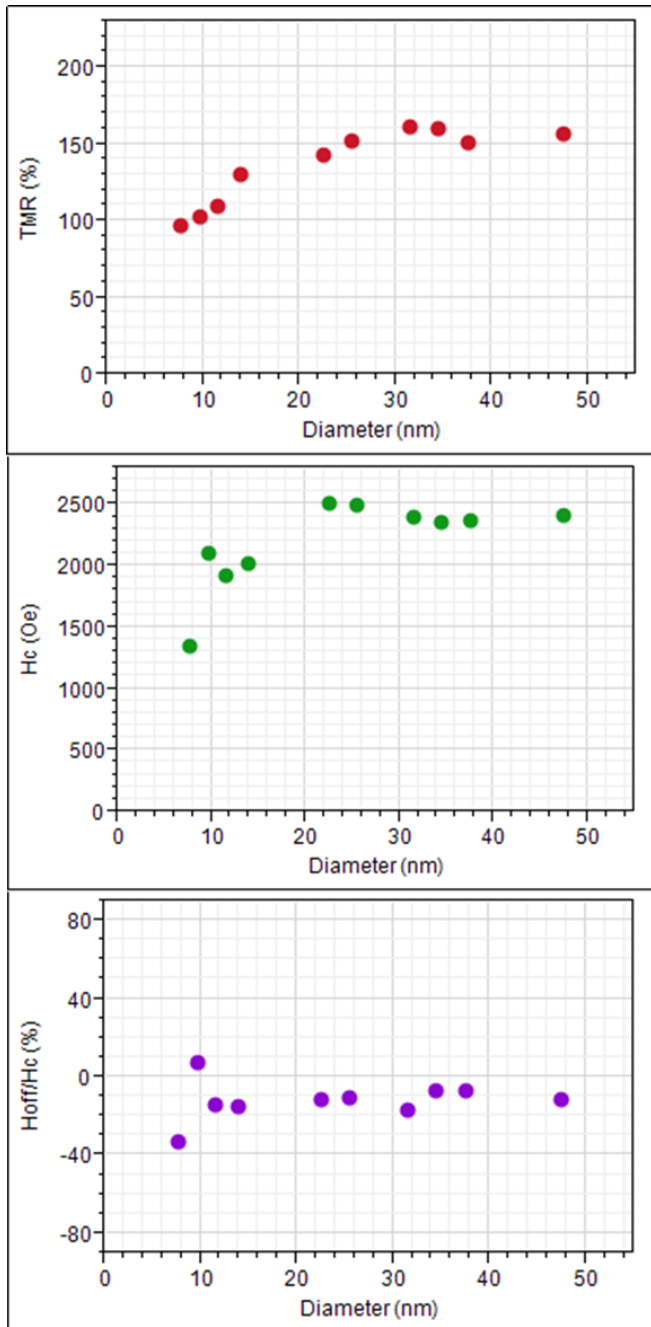


Figure 1 – (a) TMR (tunnel magnetoresistance), (b) Hc (coercivity) and (c) Hoff/Hc (offset field/coercivity, in %)

At the 2016 IEEE International Electron Devices Meeting, in a special poster session on MRAM, world-leading research and innovation hub for nano-electronics and digital technology imec presented a 8nm p-MTJ device with 100 percent tunnel magnetoresistance (TMR) and coercive field as high 1500Oe. This world's smallest device enables the establishment of a manufacturing process for high-density spin-transfer-torque magnetic random access memory (STT-MRAM) arrays that meet the requirements of the 10nm and beyond logic node for embedded non-volatile memory applications. It also paves the way for high density stand-alone applications.

STT-MRAM has the potential to become the first embedded non-volatile memory technology on advanced logic nodes for advanced applications and is also considered an alternative to conventional dynamic [random access memory](#) (DRAM). The core element of an STT-MRAM is a magnetic tunnel junction (MTJ) in which a thin dielectric layer is sandwiched between a magnetic reference layer and a magnetic free layer, where writing of the memory cell is performed by switching the magnetization of the free layer. STT-MRAMs exhibit non-volatility, high-speed, low-voltage switching and nearly unlimited read/write endurance. However, significant challenges towards commercialization remain, primarily in scaling the processes for higher densities and in increasing the device switching current.

In addressing these challenges, imec scientists have demonstrated for the first time an electrical functional p-MTJ device as small as 8nm. Despite the small dimensions, the device exhibits a high TMR of 100 percent, a coercivity (Hc) of 1500Oe

and a spin torque efficiency -the ratio of the thermal stability and switching current- as high as three. The p-MTJ stack, featuring a free layer and reference layer of CoFeB-based multilayer stacks, was developed on 300mm silicon wafers and the fabrication process is compatible with the thermal budget of standard CMOS back-end-of-line (BEOL) technology.

Moreover, imec integrated arrays of p-MTJ devices into a 1T1MTJ structure to build STT-MRAM Megabit arrays with pitches down to 100nm, proving that the technology meets the dimensional requirements for the 10nm logic node and beyond.

"STT-MRAM is a promising memory concept for future technology nodes, but its scalability towards high densities has always been challenging," stated Gouri Sankar Kar, distinguished member of technical staff coordinating RRAM, DRAM-MIMCAP, STT-MRAM activities at imec. "Our demonstration of a high-performance p-MTJ [device](#) as small as 8nm, combined with a manufacturable solution for a highly scalable STT-MRAM array will open up continued innovations for embedded non-volatile [memory](#) applications in the 10nm logic node."

Provided by IMEC

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